

Form PTO 1449
(Modified)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

LIST OF REFERENCES CITED BY APPLICANT

ATTY DOCKET NO.
230420US41YASERIAL NO.
10/673,583

APPLICANT

Andrej S. MITROVIC

FILING DATE

September 30, 2003

GROUP

2128

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
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Examiner	/Akash Saxena/ (07/26/2011)		Date Considered 07/26/2011

* Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

SHEET 2 OF 4

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 230420US41YA	SERIAL NO. 10/673,583
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Andrej S. MITROVIC	
FILING DATE September 30, 2003				GROUP 2128	
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		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
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				<input type="checkbox"/> Additional References sheet(s) attached	
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/A.S./	AAAP	JP 2003-502771	1/21/2003	JAPAN (With English Abstract)	YES	X	
/A.S./	AAAQ	WO 02/077589 A2	10/3/2002	WIPO	YES	X	
/A.S./	AAAR	KR 1999-071784	4/2/1999	Korea (with corresponding to US. Patent Application No. 5,719,796 attached as a courtesy herewith)	YES	X	
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/A.S./	AAAV	JP 2000-517473	12/26/2000	JAPAN (with English Abstract from Corresponding Case)	YES	X	
/A.S./	AAAW	JP 11-176906	7/2/1999	JAPAN (with English Abstract)	YES	X	
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